

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. KUMAKI, et al.

Serial No.: 10/572,859

371 Date: JANUARY 11, 2007

For: PHOTOSENSITIVE ELEMENT, RESIST PATTERN FORMATION
METHOD AND PRINTED WIRING BOARD PRODUCTION
METHOD

Group AU: 1795

Examiner: Amanda C. Walke

Confirm. No: 9435

AMENDMENT

Mail Stop: AMD

Commissioner for Patents

P.O. Box 1450

March 11, 2009

Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 11, 2008, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.